

JL

JCWSCS 03 AUG 2004

Aug 03 04 11:40a

4089698923

p. 1

Matrix Memory

Matrix Semiconductor, Inc.
3230 Scott Boulevard Santa Clara, California 95054
Telephone 408.969.4848 Facsimile 408.969.4849

August 3, 2004

Time: 11:30 AM
(Santa Clara, California)

To: Office of Initial Patent Examination's
Filing Receipt Corrections
Facsimile Center
P.O. Box 1450
Alexandria, VA 22313-1450

From: Pamela J. Squyres
Attorney Docket: MA-094-I
Phone: 408-869-2921

FAX NUMBER 703-746-9195

| | |
|---|-------------------------------|
| Re: Patent Application of: Shuo Gu | Examiner: Unknown |
| Serial No.: 10/767,525 | Group Art Unit: 2824 |
| Filed: 1/29/04 | Attorney Docket No.: MA-094-I |
| Title: Large Grain Size Polysilicon Films Formed by Nuclei-Induced Solid Phase Crystallization | |

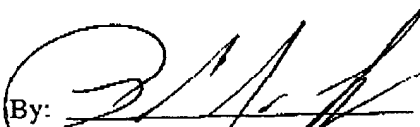
Document(s) Transmitted:

- ☐ Request for Correction (1 pg.)
- ☐ Filing Receipt (1 pg.)

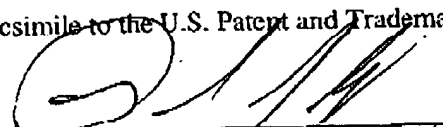
Total pages of this transmission, including the cover letter: 3

If you do not receive all of the pages described above, please telephone us at 408-869-2921
or fax us at 408-969-4849.

BEST AVAILABLE COPY

By: 
Name: Pamela J. Squyres
Reg. No.: 52,246

I hereby certify that the papers list above are being transmitted by facsimile to the U.S. Patent and Trademark
Office on the date shown below.


Pamela J. Squyres
Date of Transmission 8/3/04

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Shou Gu

Application No.: 10/767525

Filed: 1/29/2004

Title: Large Grain Size Polysilicon Films
Formed by Nuclei-Induced Solid Phase
Crystallization

Art Unit: 2824

Examiner: Unknown

Attorney Docket No.: MA-094-I

REQUEST FOR CORRECTED FILING RECEIPTOffice of Initial Patent Examination's
Customer Service Center
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Petitioner hereby requests a correction in the Filing Receipt of the above-referenced patent application.

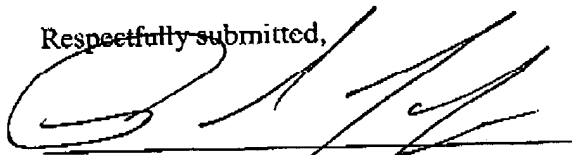
The Attorney Docket number should end with Roman numeral "I", not Arabic number "1" as on the incorrect filing receipt.

Please make the correction to the Attorney Docket number as shown below:

MA-094-I

Enclosed is a copy of the Filing Receipt with the changes noted thereon.

Respectfully submitted,

8/3/04
Date
Pamela J. Squyres
Reg. No. 52246
Attorney for ApplicantPamela J. Squyres
Matrix Semiconductor
3230 Scott Blvd
Santa Clara, CA 95054
408-869-2921**BEST AVAILABLE COPY**



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
United States Patent and Trademark Office
Address: COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, Virginia 22313-1450
www.uspto.gov

| APPL NO. | FILING OR 371 (c) DATE | ART UNIT | FIL FEE REC'D | ATTY. DOCKET NO | DRAWINGS | TOT CLMS | IND CLMS |
|------------|---------------------------|----------|---------------|-----------------|----------|----------|----------|
| 10/767,525 | 01/29/2004 | 2824 | 770 | MA-094-1 | 4 | 11 | 3 |

MATRIX SEMICONDUCTOR
3230 Scott Blvd.
Santa Clara, CA 95054

MA-094-I

CONFIRMATION NO. 5515

FILING RECEIPT



0C000000012986502

Date Mailed: 07/30/2004

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Shuo Gu, Fremont, CA; ✓

Domestic Priority data as claimed by applicant ✓

✓ This application is a DIV of 10/391,142 03/17/2003 PAT 6,713,371

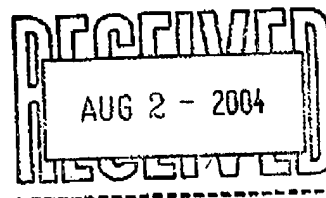
Foreign Applications

If Required, Foreign Filing License Granted: 06/17/2004

Projected Publication Date: 09/23/2004 ✓

Non-Publication Request: No

Early Publication Request: No



Title

Large grain size polysilicon films formed by nuclei-induced solid phase crystallization

Preliminary Class

365

BEST AVAILABLE COPY